Docket No. 209284US99

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Zhiyi YU, et al.

SERIAL NO: 09/842,734

GAU:

2811

FILED:

April 26, 2001

EXAMINER: HU, S.

STRUCTURE AND METHOD FOR FABRICATING SEMICONDUCTOR STRUCTURES AND EVICES USING BINARY METAL OXIDE LAYERS

REQUEST FOR EXTENSION OF TIME **UNDER 37 C.F.R. 1.136**

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

It is hereby requested that a THREE MONTH extension of time be granted to OCTOBER 17, 2004 (Sunday) for	
	filing a response to the Official Action dated:
	responding to the requirements in the Notice of Allowability dated:
	filing the Formal Drawings. The Issue Fee due has been timely filed.
	responding to the Notice to File Missing Parts of Application dated:
	filing a Notice of Appeal. A timely response to the final rejection, due has been filed.
	filing an Appeal Brief. A Notice of Appeal was filed on: MAY 17, 2004.
	A Request for Continued Examination is concurrently being filed herewith.

The required fee of \$980.00 is enclosed herewith by credit card payment and any further charges may be made against the Attorney of Record's Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

10/19/2004 HVUONG1 00000022 09842734

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980.00 OP

Respectfully Submitted,

OBLON, SPIVAK MAIER NEUS

Richard L. Treanor

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